



1fw

PATENT
SVL920040552US2
0057.0024

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	Examiner: William C. Vaughn, Jr.
J.C. Chong et al.)	
Serial No.: 10/606,028)	
Filed: June 25, 2003)	Art Unit: 2143
For: METHOD AND SYSTEM FOR)	
MONITORING PERFORMANCE)	
OF APPLICATIONS IN A)	
DISTRIBUTED ENVIRONMENT)	

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

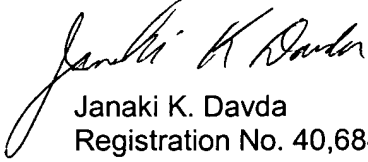
TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT

Dear Sirs:

In accordance with 37 CFR §§ 1.56, 1.97, and 1.98, enclosed please find Form PTO-1449 listing the attached references which might be deemed material to the examination of the above-identified application. Applicants submit that no fee is needed nor should be charged with the submittal of this Information Disclosure Statement (IDS) because this IDS is being submitted under 1.97(b) in that the IDS is being filed before the mailing date of a first Office Action on the merits or within three months of the filing date of a national application other than a continued prosecution application under 1.53(d). Applicants submit that a first Office Action has not been received in the above referenced case.

Nonetheless, should any fee be deemed necessary, please charge any insufficiency to Deposit Account No. 09-0460. A duplicate of this letter is enclosed for fee processing.

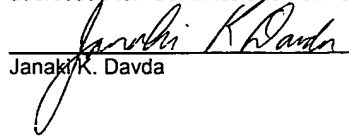
Respectfully submitted,



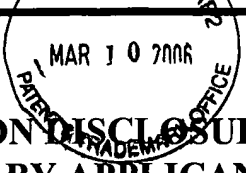
Janaki K. Davda
Registration No. 40,684
KONRAD RAYNES & VICTOR, LLP
315 S. Beverly Drive, Suite 210
Beverly Hills, CA 90212
(310) 556-7983
(310) 556-7984 (fax)

Dated: March 7, 2006

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on March 7, 2006.


Janaki K. Davda

3/7/2006
(Date)

 <p>Form 1449/PTO</p> <p>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</p> <p>(use as many sheets as necessary)</p>				Complete if Known	
		Application Number		10/606,028	
		Filing Date		June 25, 2003	
		First Named Inventor		J.C. Chong et al.	
		Art Unit		2143	
		Examiner Name		William C. Vaughn, Jr.	
		Attorney Docket Number		SVL920040552US2	
Page	1	of	1		

U.S. PATENT DOCUMENTS					
Examiner Initials	Cite No.	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number- Kind Code (if known)			
		US-6119101	09/12/2000	Peckover	
		US-6321263 B1	11-20-2001	Luzzi et al.	
		US-2002/0042896	04/11/2002	Johnson et al.	
		US-6438573 B1	08/20/2002	Nilsen	
		US-2002/0120663 A1	08/29/2002	Binns	
		US-2003/0004987 A1	01/02/2003	Glanzer et al.	
		US-2003/0065764	04/03/2003	Capers et al.	
		US-			
		US-			
		US-			
		US-			
		US-			

FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No.	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T
		Country Code- Number- Kind Code				
		WO 03/087982 A2	10-23-2003	Cynea Systems Corp.		

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T
		International Search Report dated 10-23-2003 for application WO 03/087982 A3 published 10-23-2003	
		Supplementary European Search Report dated 1-11-2006 for application EP 03742215	
		M.A. Bauer, et al., "Reference Architecture for Distributed Systems Management", IBM Systems Journal, Vol. 33, No. 3, 1994, pp. 426-444	

Examiner Signature		Date Considered	
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.			